

Appl. No. 10/565,576
Request for Corrected Filing Receipt dated 06/07/2006
Attorney Docket No. 1217-060100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/565,576 Confirmation No. 2349
Applicants : Tetsuya YOSHIDA et al.
Filed : January 23, 2006
Title : Fluid Colloid Crystal and Process for Producing Three-Dimensional
Aligned Particle Mass Therefrom
Art Unit : 1772
Examiner :
Customer No. : 28289

FACSIMILE NO. 703-305-9822
Office of Initial Patent Examination's
Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

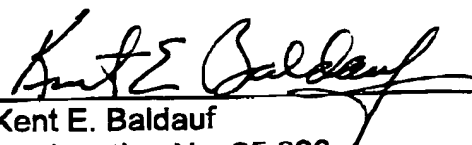
REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Attached is a marked-up copy of the official Filing Receipt for the above-identified patent application for which a Corrected Filing Receipt is hereby requested. The title has a typographical error and should read as follows:

FLUID COLLOID CRYSTAL AND PROCESS FOR PRODUCING
THREE-DIMENSIONAL ALIGNED PARTICLE MASS THEREFROM

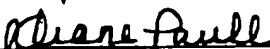
Respectfully submitted,
THE WEBB LAW FIRM

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FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office on the date set forth below.

Diane Paull
(Name of Person Mailing Paper)

 06/07/2006
Signature Date



UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/565,576	01/23/2006	1772	1900	1217060100	4	23	6

CONFIRMATION NO. 2349

FILING RECEIPT



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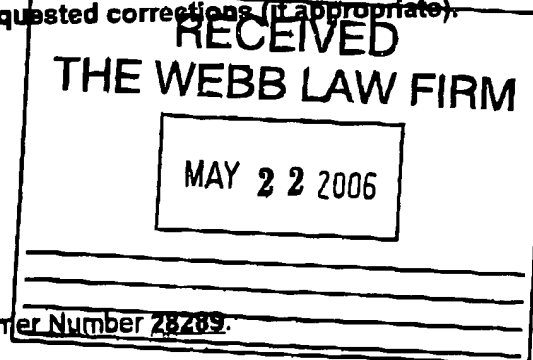
28289
THE WEBB LAW FIRM, P.C.
700 KOPPERS BUILDING
436 SEVENTH AVENUE
PITTSBURGH, PA 15219

Date Mailed: 05/15/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Power of Attorney: The patent practitioners associated with Customer Number 28289.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/10927 07/30/2004

Foreign Applications

Acceptable Request to Retrieve Priority Application Received?

JAPAN 2003284551 07/31/2003
JAPAN 2003284552 07/31/2003
JAPAN 2004009899 01/16/2004
JAPAN 2004009900 01/16/2004

NO
NO
NO
NO

If Required, Foreign Filing License Granted: 05/11/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/565,576**

Projected Publication Date: 08/17/2006

Non-Publication Request: No

Early Publication Request: No

Title

Fluid colloid crystal and process for producing three-dimensionsl aligned particle mass therefrom

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Preliminary Class

428

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